

Notice of References Cited

Application/Control No.

09/673,953

Applicant(s)/Patent Under

Reexamination
ITO ET AL.

Examiner

Paresh Patel

Art Unit

2829

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6475606	11-2002	Niwa	428/210
	C	US-5532610	07-1996	Tsujide et al.	324/757
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	N	JP 63-047382	02-1988	Japan	Yamaguchi et al.	
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	U	"Single-Crystal Silicon Embedded With Insulated Conducting Wires" August 1989, US. IBM TDB-ACC-NO: NB8908403
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
 Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.